

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE				ATTY. DOCKET NO. NSL-025	SERIAL NO. Not Yet Assigned		
LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Martin R. Roscheisen et al.			
				FILING DATE Herewith	GROUP Not Yet Assigned		
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>HEA</i>	A	M.A. Cameron et al., "Atomic Layer Deposition of SiO ₂ and TiO ₂ in Alumina Tubular Membranes: Pore Reduction and Effect of Surface Species on Gas Transport" in <u>Langmuir</u> 2000, vol. 16, pp. 7345-7555, published on the web, 6/10/2000, American Chemical Society					
EXAMINER <i>Karl Almyr</i>				DATE CONSIDERED <i>5/18/05</i>			
* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							